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To Examiner: Zeinab El-Arini	Total Pages Sent: 2
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Facsimile Number: (571) 273-8300	Transmission Date: February 7, 2006

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Ishizaki, *et al.* Docket No.: SCL-003  
Serial No.: 10/663,558 Art Unit: 1746  
Date Filed: September 16, 2003  
TITLE: Apparatus And Method For Substrate Processing

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- Certification of Facsimile Transmission (1 page)
- Election (1 page)

Respectfully submitted,

*Kristy Engeldahl*

Kristy Engeldahl  
Legal Assistant

**Confirmation Respectfully Requested**

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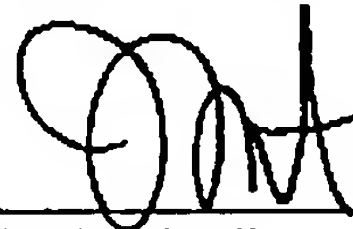
Mail Stop Amendment  
Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

ELECTION

Dear Sir:

In response to the restriction requirement set forth in the Office Action mailed on January 13, 2006, Applicant elects claims 1-15, drawn to a substrate processing apparatus, for further prosecution in the above patent application.

Respectfully submitted,



Ira S. Matsil  
Attorney for Applicant  
Reg. No. 35,272

February 7, 2006  
Date

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